Initial Tests of a MEMS Undulator at the ATF

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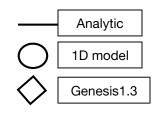


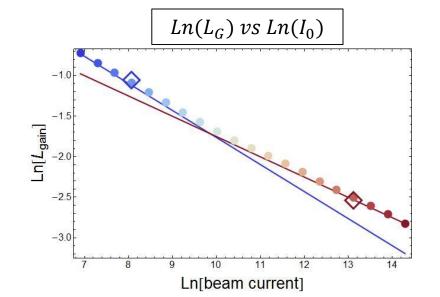


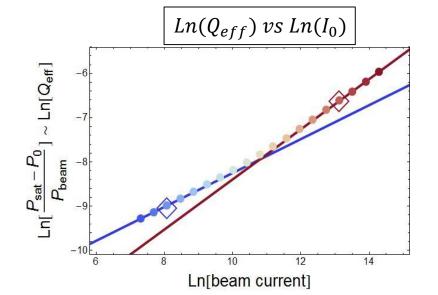
FEL Raman Regime

- Emerges in FELs with high beam currents and weak coupling between the electrons and the radiation
- Longitudinal space-charge effects come the forefront
 - $2k_{p}L_{G} > \pi$
 - Plasma wavelength is on the order of a gain-length

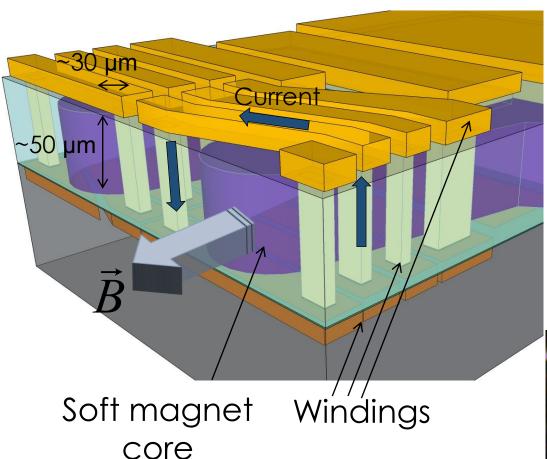
	Gain-Length	Efficiency
Compton	$L_G^C = \frac{1}{2\sqrt{3}k_u\rho} \varpropto I_0^{-1/3}$	$Q_{eff}^{C} \propto I_{0}^{1/3}$
Raman	$L_G^R \propto I_0^{-1/4}$	$Q_{eff}^R \propto I_0^{1/2}$





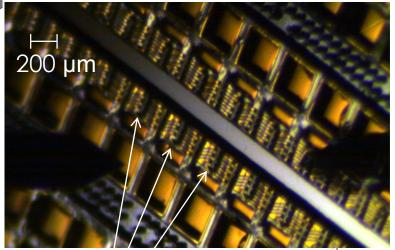


MEMS Undulator Fabrication



Potential for ~1 T fields and kT/m field gradients controlled in µsec or better timescales

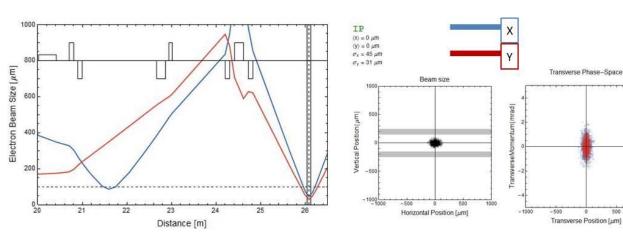
Micromachined electromagnets fabricated at UCLA



Batch-fabricated Electromagnets

Testing the MEMS Undulator at ATF

- Look for undulator synchrotron light at ATF
 - Detect with soft x-ray MCP
- Take cue from the DWA experiment performed by G. Andonian et al. [4]
 - Similar dimensions of slab-symmetric stricture and undulator
- Elegant simulations show that focusing through the undulator is possible with the quad triplet upstream of the plasma chamber



Beam and undulator parameters			
Beam Energy	65 MeV		
Beam Charge	1 nC		
Transverse Size	$\sigma_x \times \sigma_y = 45 \times 31 \ \mu m$		
Beta Function	$\approx 10~cm$		
Undulator period	$800~\mu m$		
Gap	$200~\mu m$		
K parameter	0.08		
Central wavelength	24.9 nm $= 49.9 eV$		
Bandwidth	$\frac{1}{N_u} = 0.01$		
Opening angle	$ heta_{rad} = rac{1}{\gamma \sqrt{N_u}}$		

= 0.79 mrad

